



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Mohammad B. SHABANI et al.

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Atty. Docket No.: JG-SU-5038/500577.20021

**METHOD FOR ANALYZING IMPURITIES  
IN A SILICON SUBSTRATE AND  
APPARATUS FOR DECOMPOSING  
SILICON SUBSTRATE THROUGH  
VAPOR-PHASE REACTION**

Commissioner for Patents  
P.O. Box 1450  
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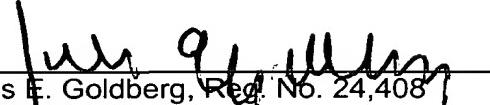
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Respectfully submitted,

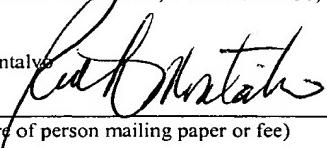
  
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